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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Confirmation No.: 3248

KITANO et al

Atty. Ref.: 160-513

Serial No. 10/594,422

Group: 2828

Filed: September 26, 2006

Examiner: Michael Carter

For: NITRIDE SEMICONDUCTOR LASER ELEMENT

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February 12, 2009

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

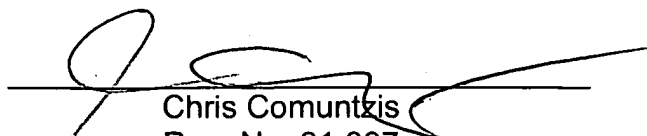
STATEMENT

Pursuant to the requirement of the Interview Summary of January 7, 2009, which was received January 13, 2009, the undersigned states that the Interview Summary is accurate in its brief description of the issues discussed with the Examiner during the interview of January 6, 2009. Nothing further is believed to be required in response to the Interview Summary however the Office is requested to contact the undersigned if otherwise.

Respectfully submitted,

NIXON & VANDERHYE P.C.

By:


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